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| DATE OF DEPOSIT        | 42663               |

Our File No. 9281-4621

Client No. K2F US99641

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| In re App             | olication of:  | )                      |  |
|-----------------------|--|------------------------|--|
| Miki Ono              | et al.   | )                      |  |
| Serial No             | o. To be Assigned  | )                      |  |
| Filing Date: Herewith |  | ) Group Art Unit: 2828 |  |
|                       | ptical Semiconductor Device<br>rovided With High-NA Lens | )<br>)                 |  |

## PRELIMINARY AMENDMENT

Mail Stop Patent Application Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Prior to examination of the above-identified application, please amend the application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks begin on page 9 of this paper.